

Response of alumina resistance to trace concentrations of acetone vapors at room temperature

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The study demonstrates that resistivity of an alumina wafer is highly sensitive to trace concentrations of acetone vapors at room temperature. Though, a thermal pretreatment is necessary to precede the room-temperature sensing of acetone vapors, whilst the sensitiveness increases with the pretreatment temperature. This advocates the alumina being suitable for an adequate acetone sensor in the ppm range. A plausible mechanism of the response is discussed.

Key words: gas sensor, chemiresistor, acetone, Al₂O₃, alumina

1 Introduction

The exhaled breath of a human contains a variety of volatile organic compounds (VOC); their presence and concentration could be suggestive of the health condition. For example, the background value of 0.76 ppmv acetone vapors associated with a healthy person rises with a diabetes patient; the value of 1.7 [1] and even as high as 10 ppmv [2] were reported. A simple chemiresistor-inferred sensor capable to detect acetone vapors could facilitate the development of a personal instrument for daily monitoring of diabetes patients, thus providing an affordable non-invasive alternative to blood testing.

The fundamental structure of the chemiresistor consists of a gas-sensitive layer supported by an electrically insulating substrate, the former being the most frequently based on a semiconducting metal oxide [3-5]. The maximal sensing response occurs typically at elevated operating temperature up to several hundreds of degrees Celsius. The stoichiometry of compounds such as metal oxides is usually temperature-dependent and the stabilization of sensor transport properties at elevated operating temperature may request long start-up time of tenths of minutes. The lengthy onset can lead to a resistance drift with magnitude comparable to the gas-induced response. Therefore, the elevated operating temperature can be in general disadvantageous due to stability issues and high power consumption. A room-temperature operated sensor would apparently avoid drawbacks related to elevated operating temperature, yet such sensors have been merely intermittently reported (see *eg* [6-7] and remained a challenge.

Alumina has been commonly employed in the role of the supporting substrate for gas-sensitive films for its ex-

cellent insulating properties and stability at high temperatures. In this study, we demonstrate that the supporting alumina itself can show a marked response to trace concentration of acetone vapors even at room temperature if subjected to a thermal pretreatment, and can be thereby classified as the virtually room-temperature sensor of acetone vapors.

2 Experimental

The alumina chips sized 2 × 2 mm cut out from a 0.25 mm thick wafer (purity 99.0%, Goodfellow Cambridge) were equipped with interdigital planar electrodes (distanced 50 μm) on the front side allowing the film resistivity characterization, and an integrated resistive heater incorporated on the back side. The electrodes (see the drawing sketched in Fig. 1) were made of 50 nm Ti/500 nm Pt films. The chips were soldered into a commercial TO-4 socket.

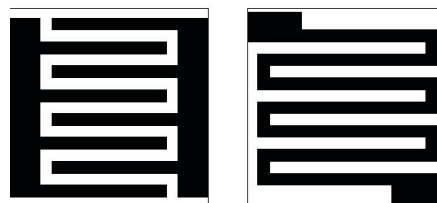


Fig. 1. Schematic drawing of interdigital electrodes and the resistive meander on the front and back sides (left and right images, respectively) of the Al₂O₃

The samples were annealed in the gas-sensing probing cell at temperatures up to 440 °C in synthetic air, whilst

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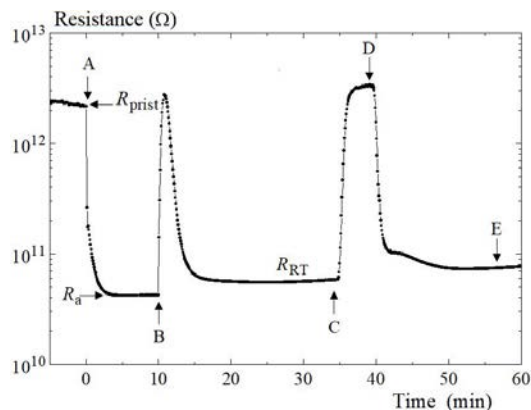


Fig. 2. Typical probing cycle consisting of the thermal pretreatment (from *A* to *B*) and the response to acetone (from *C* to *D*)

the heating was achieved by means of the integrated resistive heater.

The sensing response was identified as the resistance measured between the interdigital electrodes upon the exposure of acetone vapors diluted in synthetic (dry) air (R_{acet}) ratioed to the resistance obtained in pure synthetic air (R_{air}). The resistance was standardly examined at constant operating voltage of 10 V applied across the interdigital electrodes. Varying acetone concentration was controlled by mixing of synthetic air and a certified mixture of 20 ppm acetone vapors in synthetic air (SIAD, Slovakia) by means of mass-flow controllers. Standardly, the total medium flow of 10 sccm was kept constant for any (hence also zero) acetone concentration. The volume of the probing cell including supply pipes was about 30 cm³.

Raman spectra were collected at room temperature using a confocal Raman spectrometer (WITec Alpha300, Ulm, Germany) equipped with a laser operating at the wavelength of 531.93 nm (Spectra Physics Excelcior 532-60 laser). The excitation power of the laser and the integration time for a spectrum were set to 1 mW and 10 min, respectively. The probed area and depth were about 500 nm (diameter) and 1 μm, respectively.

X-ray photoemission spectra were recorded using a Thermo Scientific K-Alpha XPS system (Thermo Fisher Scientific, UK) equipped with a micro-focused, monochromatic Al Kα X-ray source (1486.7 eV). An X-ray beam of 400 μm size was used at 6 mA × 12 kV. The survey spectra were acquired in the constant analyzer energy mode with pass energy of 200 eV. Narrow regions were collected using the pass energy of 50 eV. Charge compensation was achieved with the system dual beam flood gun. The Thermo Scientific Advantage software (the version 5.9904, Thermo Fisher Scientific) was used for the digital acquisition and the data processing. Spectral calibration was determined by using the automated calibration routine and the internal Au, Ag and Cu standards supplied with the K-Alpha system.

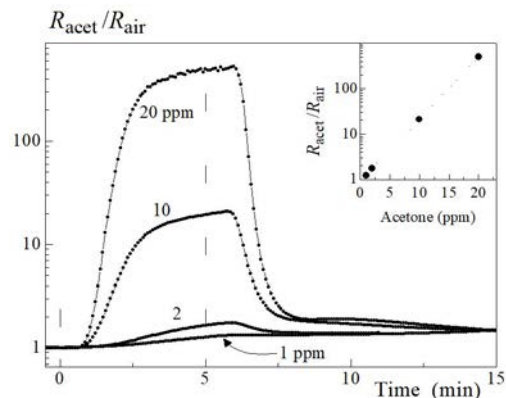


Fig. 3. Dynamic responses of the alumina to various concentrations of acetone vapors diluted in air (indicated in ppm units next to the dependences) recorded at RT

3 Results

The alumina, which has been commonly employed in the role of the substrate, is supposedly inert to analytes. Indeed, we observed no sensitivity to acetone, yet, this has applied for the pristine alumina only. In contrast to the untreated alumina, the annealed alumina can display a marked response to acetone vapors. Figure 2 illustrates the resistance evolution of the alumina chip during the cycle consisted of the thermal pretreatment, cooling, and exposure to acetone vapors. The resistance of the pristine alumina, R_{prist} , plummets by almost two orders of magnitude to the value R_a upon the warming the alumina (the start is indicated by the label *A*) up to the annealing temperature (of 355°C here).

Upon the switching OFF the heater (indicated by *B*) the sample is brought near to RT in less than ten seconds, and the RT retains for the rest of the cycle, accordingly up to the label *E*. After the switching the heater OFF, the resistance at first increases near to R_{prist} , then it drops to a post-annealed value R_{RT} , whilst the inequality $R_a < R_{\text{RT}}$ holds. The sample was kept in the dry-air flow of 10 sccm during both the pretreatment and the cooling till to the label *C*. A mixture of 20 ppm of acetone vapors diluted in the dry air (likewise with the flow of 10 sccm) was supplied during the 5 min interval between *C* and *D*. The segment from *C* to *E* refers to the dynamic response curve (DRC). We remind that the sensing temperature, which refers to the temperature of the sensor while probing the dynamic response curve, was amounted to RT. The $R_{\text{acet}}/R_{\text{air}}$ ratio gives the pronounced value of about 60. Note that – in reference to Fig. 2 – R_{air} was identified with R_{RT} deduced at the time labeled *C*, while R_{acet} was assigned to the maximal resistance achieved upon the acetone exposure, accordingly read at the label *D*.

The decreased/increased resistance of a chemiresistor upon the adsorption of an analyte is commonly referred to the *n*-/*p*-type response and is often observed upon the adsorption of reducing/oxidizing species (*eg* CO, acetone/*eg* NO₂), see *eg* [3-4]. Referring to Fig. 2, the alu-

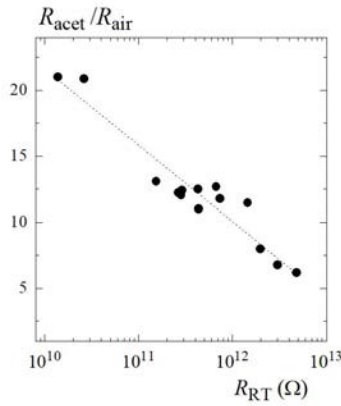


Fig. 4. $R_{\text{acet}}/R_{\text{air}}$ of alumina at RT upon the 5 min-exposure of 10 ppm of acetone correlated with the resistance R_{RT} (see Fig. 2); the dashed line indicates the linear fit.

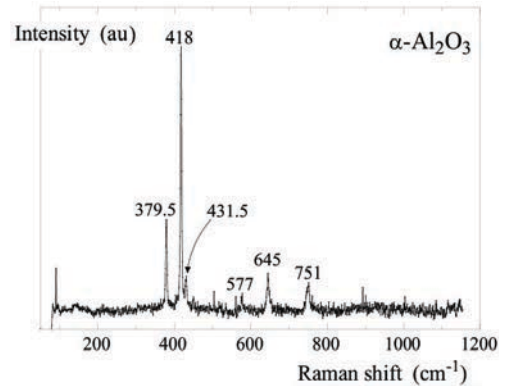


Fig. 5. Raman spectrum of the employed alumina, the constant background was subtracted.

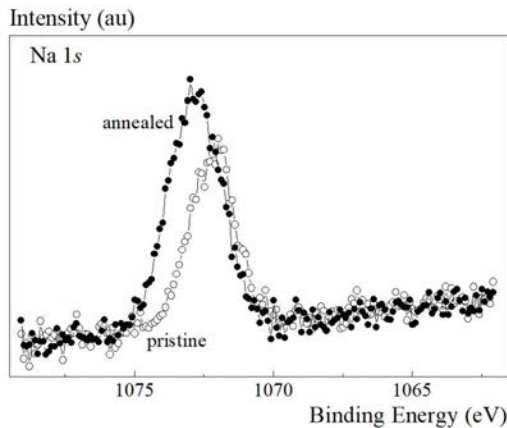


Fig. 6. Na 1s core level of the $\alpha\text{-Al}_2\text{O}_3$: the pristine sample (empty symbols) and 3 hours after the 15-min lasted annealing in dry air at 440°C (full symbols)

mina shows the p -type response to the acetone exposure, accordingly the trend is opposite to the generally assumed one, though exceptions have been already reported [3].

A certain delay of both the onset and decay of the dynamic response with the respect of the labels C and D corresponding to the switching ON and OFF of the acetone mixture supply, respectively, is due to a delay necessary for the exchange of gaseous ambient in the probe cell. The concentration change in the probe cell is not immediate upon the switching the probed mixture ON, but it approaches asymptotically to the adjusted value. Note that the volume of the probing cell including supply pipes matches with the 180 seconds-lasting gas flow of 10 sccm.

Figure 3 presents the dynamic response curves (DRC) of alumina to 1,2,10, and 20 ppm of acetone. Note that the response exceeding 500 was detected upon 20 ppm of acetone. The inset shows the response $R_{\text{acet}}/R_{\text{air}}$ versus the acetone concentration dependence. The acetone exposures lasted 5 min, the vertical dashed lines indicated switching ON/OFF of the valve with the acetone mix-

ture. The R_{RT} 's for particular DRCs were in the interval $(1 \text{ to } 2.5) \times 10^{10} \Omega$. The inset traces the response versus acetone concentration dependence extracted from the presented DRCs.

The response is reciprocally affected by the resistance R_{RT} (Fig. 4), which reflects the modification of alumina properties by the thermal pretreatment; specifically, both R_a and R_{RT} decreases with the increasing annealing temperature (not shown here). The dependence of the response $R_{\text{acet}}/R_{\text{air}}$ on R_{RT} examined upon the 10 ppm-acetone exposure suggests that the proportion $R_{\text{air}}/R_{\text{acet}} \propto \log(R_{\text{prist}} - R_{\text{RT}})$ holds.

The "sensing stage" of alumina – defined by the inequality $R_{\text{RT}} \ll R_{\text{prist}}$ here – is not stable at RT, as it is suggested by a slow gradual increase of R_{RT} at RT; as an example, R_{RT} increases from ca $5.55 \times 10^{10} \Omega$ to $5.7 \times 10^{10} \Omega$ in the course of 10 min (see the region of DRC afore the label C in Fig. 2). The increasing R_{RT} (with the time elapsed after the annealing) results in the decreasing response as suggested by the dependence shown in Fig. 4. To eliminate the effect of the gradual relaxation of the pretreated alumina on the response, the same thermal treatment was performed immediately before probing each DRC shown in Fig. 3, thereby resulting in virtually the same R_{RT} at the beginning of each DRC characterization.

4 Discussion

The alumina is a common active element in humidity sensors [8]. Yet, we presume that the resistance decrease to R_{RT} after the thermal pretreatment is not explicable by means of humidity influence – though the water adsorption would admittedly result in the resistance decrease – since the entire cycle exemplified in Fig. 2 was carried out in dry synthetic air.

Gas-sensing properties of alumina-based films, though functionalized by *eg* metal or metal oxides additives, were reported [9-10]. Nevertheless, the insensitiveness the untreated alumina substrate to analytes had been tacitly

presumed. The view was recently undermined in the study by Kita *et al*[11], where sensing responses to various gases – though at high concentrations – were demonstrated, such as NO (ca 500 ppm), NO₂ (ca 100 ppm), C₃H₈ (ca 650 ppm), and NH₃ (ca 50 ppm). It should be mentioned that our alumina samples showed virtually no response to 5 ppm of NO₂ neither at RT not at elevated temperature of 400°C.

Here, the influence of the thermal pretreatment on alumina properties was investigated by Raman and x-ray photoemission spectroscopies. The observed vibrations in Raman spectrum (Fig. 5) indicate the α phase [12,13]. The spectra were insensitive to the annealing in dry air up to the investigated temperature of 440°C. Compared to the δ , θ and γ phases of Al₂O₃, the α -Al₂O₃ phase was reported to contain the highest concentration of sodium ions [13]. Indeed, the presence of sodium was verified in the pristine sample by the XPS method (the empty symbols in Fig. 6), namely the concentration of ca 0.5% was observed. Importantly, the Na concentration higher by a factor of about 1.6 was measured three hours after the annealing (the full symbols in Fig. 6) suggesting that the annealing induces the enrichment with sodium in the near-surface region. Besides, the elemental analysis revealed the presence of calcium and magnesium in the alumina. Calcium concentration being of about 0.5% was not affected by the annealing. Magnesium concentration showed the trend similar – yet less pronounced – to sodium concentration; namely, its concentration has arisen by about 15% due to the annealing.

Since the lesser relative changes of magnesium concentration compared to that of sodium, we presume that the surface properties of alumina are dominantly affected by sodium. The sensing mechanism itself is not fully understood so far, nevertheless, we propose a model as follows. The pre-annealing of alumina induces an agglomeration of Na⁺ ions near the alumina surface (Fig. 6), which is manifested by the decrease of the room-temperature resistance (R_{RT}); we remind here that the alumina resistance was measured laterally. By this means modified alumina is effective in sensing the acetone. We recall that this state is not stable at RT as it is manifested by gradually increasing resistance towards the magnitude typical for the pristine sample in the course of tenths of hours. The resistance increase is owing to diffusion of the near-surface agglomerated sodium ions into the bulk of alumina. Upon the adsorption of acetone molecules, the near-surface agglomerated sodium atoms are presumably immobilized due to an interaction between the electron pair of the acetone molecule and the Na⁺ ion thus forming an acid-basic pair in terms of Lewis theory [14]. The immobilization of the Na⁺ ions entails the resistance increases, thereby demonstrating the *p*-type response. Unlike acetone adsorption, the adsorbed NO₂ molecules do not virtually affect the alumina resistance. This is presumably due to a weaker interaction between the electron pair of NO₂ molecule and Na⁺ ion, as suggested by the markedly lower dipole moment of 0.316 D of the former

in comparison to that of acetone amounted to 2.88 D [15], where D refers to the debye unit.

5 Summary

The resistance of the alumina wafer displays a high sensitivity to the exposure of acetone vapors in the ppm range at room temperature provided that a thermal pretreatment of the alumina is carried out prior the sensing characterization.

The thermal pretreatment enriches the surface region of alumina by sodium ions, originally distributed in the bulk of alumina. It is presumed that sodium ions are immobilized by interaction with acetone molecules causing the resistance increase upon acetone exposure, thereby the *p*-type response.

The stage with higher sodium concentration near the alumina surface, which means the condition susceptible for the acetone detection, slowly relaxes at room temperature towards the magnitude of the pristine sample. Nevertheless, the observed effect suggests that the alumina is applicable in capacity of a room temperature-operated sensor of acetone vapors.

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